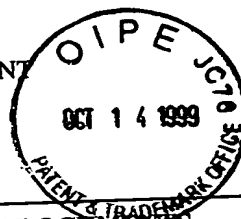37 CFR 1.501
INFORMATION DISCLOSURE STATEMENT
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Docket No. P99,1690	Serial No. 09/381,839 FAX RECEIVE
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Cml	AM	EP 0 662 773 A1	07-12-95	Europe				X
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| Examiner Colin Larose | Date Considered 6-24-02 |

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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